

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
		Examiner Kevin M Bernatz	Art Unit 1773	Page 1 of 1

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	B	US-5,480,733	01-1996	Okumura et al.	428/694T
	C	US-6,010,795	01-2000	Chen et al.	428/611
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	N	WO98-16923	04-1998	PCT	Chen et al.	
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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